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U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10026653	12/27/2001	438		2812	

\*\*APPLICANTS: Ishida Masaya; Miyazawa Takashi;

\*\*CONTINUING DATA VERIFIED: *none*

\*\* FOREIGN APPLICATIONS VERIFIED: *any*  
JAPAN 2000-403230 12/28/2000

PG-PUB DO NOT PUBLISH ☐ RESCIND ☐

Foreign priority claimed ☒ yes ☐ no  
35 USC 119 conditions met ☒ yes ☐ no  
Verified and Acknowledged Examiners's initials *any*

ATTORNEY DOCKET NO  
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TITLE : Manufacturing method of molecular film pattern, molecular film pattern, manufacturing method of semiconductor device, semiconductor device, manufacturing method of electro-optical dev

U.S. DEPT. OF COMMERCE PAT. & TM. PTO-435L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>Assistant Examiner</b>	<b>CLAIMS ALLOWED</b>	
<i>01/27/03</i>			Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>Primary Examiner</b>	<b>DRAWING</b>	
Amount Due \$	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	<b>Application Examiner</b>	
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